

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Application of: Jia-Xing Lin

Confirmation No. 5673

Serial No.: 10/772,511

Group Art Unit: 2812

Examiner: Patel, Reema

Filed: February 5, 2004

TKHR Docket No. 250914-1020

Tsai, Lee & Chen Ref. NP-1761-US

For: Method of Controlling Polysilicon  
Crystallization

**AMENDMENT AND RESPONSE TO OFFICE ACTION**

Mail Stop - Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

The Office Action mailed December 14, 2007 has been carefully considered. In response thereto, please enter the following amendments and consider the following remarks.